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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/563,499	08/24/2006	Michael Halama	RECP:112 US	8286
24041 SIMPSON & S	7590 12/17/2007 SIMPSON PLIC		EXAMINER	
SIMPSON & SIMPSON, PLLC 5555 MAIN STREET			BUI, BRYAN	RYAN
WILLIAMSVILLE, NY 14221-5406			ART UNIT	PAPER NUMBER
			2863	
			MAIL DATE	DELIVERY MODE
		•	12/17/2007	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

		Application No.	Applicant(s)
Office Action Summary		10/563,499	HALAMA ET AL.
		Examiner	Art Unit
		Bryan Bui	2863
Period fo	The MAILING DATE of this communication app or Reply	ears on the cover sheet	with the correspondence address
A SH WHIC - Exte after - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR REPLY CHEVER IS LONGER, FROM THE MAILING DANSIONS of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication. Or period for reply is specified above, the maximum statutory period were to reply within the set or extended period for reply will, by statute, reply received by the Office later than three months after the mailing ed patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUN 36(a). In no event, however, may a vill apply and will expire SIX (6) MC cause the application to become	NICATION. a reply be timely filed ONTHS from the mailing date of this communication. ABANDONED (35 U.S.C. § 133).
Status			
2a) <u></u> —	Responsive to communication(s) filed on This action is FINAL . 2b) This Since this application is in condition for allowar closed in accordance with the practice under E	action is non-final. nce except for formal ma	•
Dispositi	ion of Claims		
5)□ 6)⊠ 7)⊠	Claim(s) <u>1-13</u> is/are pending in the application. 4a) Of the above claim(s) is/are withdraw Claim(s) is/are allowed. Claim(s) <u>1-5,10,12 and 13</u> is/are rejected. Claim(s) <u>6-9 and 11</u> is/are objected to. Claim(s) are subject to restriction and/or		
Applicati	on Papers		
10)⊠	The specification is objected to by the Examine The drawing(s) filed on <u>04 January 2006</u> is/are: Applicant may not request that any objection to the or Replacement drawing sheet(s) including the correction to the or declaration is objected to by the Example 1.	a)⊠ accepted or b)□ drawing(s) be held in abeya on is required if the drawin	ance. See 37 CFR 1.85(a). ng(s) is objected to. See 37 CFR 1.121(d).
Priority u	ınder 35 U.S.C. § 119		•
a)l	Acknowledgment is made of a claim for foreign All b) Some * c) None of: 1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the prior application from the International Bureau See the attached detailed Office action for a list of	s have been received. s have been received in ity documents have bee (PCT Rule 17.2(a)).	Application No n received in this National Stage
2) Notic 3) Inform	t(s) e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO/SB/08) r No(s)/Mail Date 1/4/06.	Paper No	Summary (PTO-413) o(s)/Mail Date Informal Patent Application

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DETAILED ACTION

Specification

1. Applicant is reminded of the proper language and format for an abstract of the disclosure.

The abstract should be in narrative form and generally limited to a single paragraph on a separate sheet within the range of 50 to 150 words. It is important that the abstract not exceed 150 words in length since the space provided for the abstract on the computer tape used by the printer is limited. The form and legal phraseology often used in patent claims, such as "means" and "said," should be avoided. The abstract should describe the disclosure sufficiently to assist readers in deciding whether there is a need for consulting the full patent text for details.

The language should be clear and concise and should not repeat information given in the title. It should avoid using phrases which can be implied, such as, "The disclosure concerns," "The disclosure defined by this invention," "The disclosure describes," etc.

2. The abstract of the disclosure is objected to because the phraseology "comprises", it should change to --includes-- to avoid the legal phraseology often used in patent claims. Correction is required. See MPEP § 608.01(b).

Claim Rejections - 35 USC § 112

- 3. The following is a quotation of the second paragraph of 35 U.S.C. 112:
 The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.
- 4. Claim 2 is rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.
- 5. In claim 2, the term "by a drop in potential" is incomplete. What is potential that applicant want to regards to the invention?

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Claim Rejections - 35 USC § 103

- 6. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 7. Claims 1-5, 10, 12-13 are rejected under 35 U.S.C. 103(a) as being unpatentable over Hase et al (US 20010030739).

With respect to claim 1, Hase et al teach a device for wafer inspection which comprises a stage for mounting a wafer thereon for inspection, the stage being displaceable in two direction perpendicular to one another (figure 1, wafer stage 35, and figure 2); the stage being provided with a plurality of air nozzles (figures 3, items 47, 49); at least one valve (figure 1, chuck valve 33), at least one electric control unit (figure 1, at least one of 101-104), at least one valve connected to the at least one electric control unit (figure 1, connection between valve chuck in wafer stage to control unit). Hase et al do not implicitly teach wherein the at least one valve is configured so that normal pressure prevail in the air nozzles when the electric control unit delivers a corresponding signal. However, Hase et al disclose wafer stage controller for controlling driving of wafer stage, main controller for controlling whole apparatus sending instruction to prism controller to rotate or stop the wedge prism, controlling the reticle stage controller and wafer stage controller and determining the output signal (par 0046). and flowing gas in flow paths 47 or exhaust gas in flow path 49 using lubricating gas (figure 4) that stator coil and magnet (formed of linear motor as known in the art, see ref

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EP 1300932 A2/U.S. Patent No. 6864602 as indicated in search report submitted by applicant in the record) driving for efficiency gas at the atmosphere in the housing (par 0062). Therefore, it would have been obvious to one of ordinary skill in the art to realize the teachings of Hase et al as mentioned above commonly provide the appropriate flow rate of gas (such pressure flow influence in the flow path controlling by controller unit). The suggestion would made the device prevent the over flow and back flow may occur.

With respect to claims 2-5, as mentioned above, Hase et al teach the features of the claimed invention, and the status and state of the operation signal is effectively by the voltage, current to motor, rotor, coil, driving member, instruction from controller, motor, rotor use for moving the stage along the two displaceable direction (figures1-2, par 0046).

With respect to claims 10, 12-13, Hase et al further teach the stage comprises a receptacle for inspection of the wafer, at least one valve is provided on the air nozzle/air supply line for flowing/ supplying (figures 1, 3 and par 0061).

Allowable Subject Matter

8. Claims 6-9, 11 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Conclusion

9. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Bryan Bui whose telephone number is 571-272-2271. The examiner can normally be reached on M-TH from 5:30am to 4:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John E. Barlow can be reached on 571-272-2269. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

BB

12/9/2007

BRYAN BUI PRIMARY EXAMINER